

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 200312702-1	APPLICATION NO. 10/825,841	CONFIRMATION NO.
	APPLICANT Arjang Fartash		
	FILING DATE herewith	GROUP	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
	1A				
	1B				
	1C				
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	1I				
	1J				
	1K				

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
	1L					
	1M					
	1N					
	1O					
	1P					

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

<i>M</i>	1Q	DW Face and DE Prober, J. Vac. Sci. Technol. A, Vol. 5, No. 6, Nov/Dec 1987, "Nucleation of body-centered-cubic tantalum films with a thin niobium underlayer", pp. 3408-3411
<i>M</i>	1R	DW Face, ST Ruggiero, and DE Prober, J. Vac. Sci. Technol. A, Vol. 1, No. 2, Apr-June 1983, "Ion beam deposition of Nb and Ta refractory superconducting films", pp. 326-330
<i>M</i>	1S	DW Matson, MD Merz, and ED McClanahan, J. Vac. Sci. Technol. A, Vol. 10, No. 4, Jul/Aug 1992, "High rate sputter deposition of wear resistant tantalum coatings", pp. 1791-1796

EXAMINER

Carroll

DATE CONSIDERED

*9/30/05**20040415*